

Applicant: Kwang-Il Kim

Serial No. not yet assigned Examiner: not yet assigned

Filing Date: February 3, 2004 Art Unit: not yet assigned

For: PHOTORESIST SUPPLY APPARATUS FOR PREVENTING PHOTORESIST LOSS
THROUGH DRAIN LINE

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
_____	_____	6,017,393	1/25/2000	Liu, et al.		

FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
_____	_____	2000-0008956	5/25/2000	Korea	Lee, et al.

OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language Abstract of Korean Patent Publication No. 2000-0008956

Examiner: _____

Date Considered: _____